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	Application No.	Applicant(s)
Madica of Allamahilita.	10/816,311	LINDERT ET AL.
Notice of Allowability	Examiner	Art Unit
	Joseph Nguyen	2815
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
1. This communication is responsive to the amendment filed on 6/12/2006.		
2. The allowed claim(s) is/are <u>1-7,10,12-19 and 43-51</u> .		
3. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  a) All b) Some* c) None of the:		
Certified copies of the priority documents have been received.		
2. Certified copies of the priority documents have been received in Application No		
3. Copies of the certified copies of the priority documents have been received in this national stage application from the		
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.  THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		
4. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.		
5. CORRECTED DRAWINGS ( as "replacement sheets") must be submitted.		
(a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review ( PTO-948) attached		
1)  hereto or 2) to Paper No./Mail Date		
(b) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date		
Paper No./Mail Date  Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).		
DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.		
Attachment(s)  1. Notice of References Cited (PTO-892)	5 \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \	Patent Application (PTO-152)
	6. ☐ Interview Summary	• • • • • • • • • • • • • • • • • • • •
2. Notice of Draftperson's Patent Drawing Review (PTO-948)		
3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 6/12/06 2 09/05 07/05	Paper No./Mail Da 08), 7. 🔀 Examiner's Amendr	ment/Comment
4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. X Examiner's Statement	ent of Reasons for Allowance
	9.  Other	

## **DETAILED ACTION**

## **EXAMINER'S AMENDMENT**

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Michael Bernadicou on 08/02/2006.

Please amend claims as follows:

In claim 1, lines 8-9, delete "silicon germanium body" and insert "semiconductor body".

In claim 16, lines 8-9, delete "silicon germanium body" and insert "silicon carbon alloy body".

In claim 51, line 8, delete "strained semiconductor body" and insert "semiconductor body".

## Allowable Subject Matter

Claims 1-7, 10, 12-19 and 43-51 are allowed.

The following is an examiner's statement of reasons for allowance:

The reference (s) of record do not teach or suggest, either singularly or in combination at least the limitation of "said semiconductor capping layer is formed thicker

on the top surface of said silicon germanium body than on the sidewalls of said silicon germanium body" for claim 1; "said silicon film is formed thicker on the top surface of said silicon germanium body than on the sidewalls of said silicon germanium body" for claims 10, 16 and 43; said semiconductor capping layer is formed thicker on the top surface of said semiconductor body than on the sidewalls of said semiconductor body" for claims 44 and 51.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

## Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Joseph Nguyen whose telephone number is (571) 272-1734. The examiner can normally be reached on Monday-Friday, 7:30 am- 4:30 pm. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Ken Parker can be reached on (571) 272-2298. The fax phone number for the organization where this application or proceeding is assigned is (571) 273-8300 for regular communications.

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JN August 2, 2006.

KENNETH PARKER
SUPERVISORY PATENT EXAMINER